INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 19, 2026

IGI Report Number	LG847632852
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND MODIFIED BRILLIANT
Measurements	6.40 - 6.48 X 3.90 MM

GRADING RESULTS

Carat Weight	1.08 CARAT
Color Grade	E
Clarity Grade	VVS 2

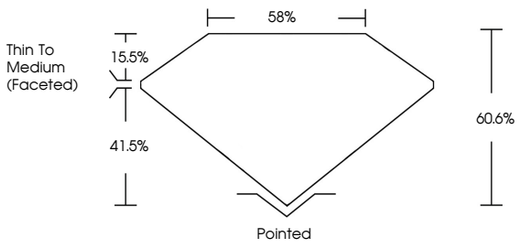
ADDITIONAL GRADING INFORMATION

Polish	VERY GOOD
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG847632852

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG847632852
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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Measurements 6.40 - 6.48 X 3.90 MM

GRADING RESULTS
Carat Weight 1.08 CARAT
Color Grade E
Clarity Grade VVS 2

58%
Thin To Medium (Faceted)
15.5%
41.5%
60.6%
Pointed

ADDITIONAL GRADING INFORMATION
Polish VERY GOOD
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG847632852
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

IGI

October 19, 2026
IGI Report No LG847632852
ROUND MODIFIED BRILLIANT
6.40 - 6.48 X 3.90 MM
Carat Weight 1.08 CARAT
Color Grade E
Clarity Grade VVS 2
Depth 60.6%
Table 58%
Girdle Thin To Medium (Faceted)
Culet Pointed
Polish VERY GOOD
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG847632852
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa